

Packet No.: 005920 USA/PMG/PCTRL

PATENT/OFFICIAL

2823/18  
JFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of

SHANMUGASUNDRAM et al.

Serial No. 09/943,383

: Group Art Unit: 2823

Filed: August 31, 2001

: Examiner: William D. Coleman

For: IN SITU SENSOR BASED CONTROL OF SEMICONDUCTOR PROCESSING  
PROCEDURE

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

PTO did not receive the following disclosure(s) <u>see #180, 80</u>
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Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This submission does not constitute a representation that a search has been made or that no better art exists and does not constitute an admission or representation that any of the listed documents is material or constitutes prior art. If it should be determined that any of the listed

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**Serial No. 09/943,383**

documents does not constitute prior art under the United States law, Applicants reserve the right to present to the Office the relevant facts and law regarding the appropriate status of such document.

The references listed on Sheet 1 of the attached PTO-1449 Forms were cited in a patentability investigation and/or a corresponding foreign or PCT application relating to the above-referenced application. The remaining references are from potentially related patent applications, and possibly other sources.

The referenced patent application was allowed on October 5, 2004. Applicant petitions for consideration of the enclosed documents by the Examiner. The petition fee of \$180.00 pursuant to 37 CFR § 1.17(p) is attached. The Commissioner is authorized to charge any deficiency in any fees pursuant to 37 CFR § 1.17 associated with this communication and to credit any excess payment to Deposit Account No. 08-0219.

Respectfully submitted,

Wilmer Cutler Pickering Hale and Dorr LLP

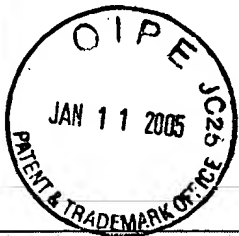


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**INFORMATION DISCLOSURE  
CITATION IN AN  
APPLICATION**



(PTO-1449)

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APPLICANT  
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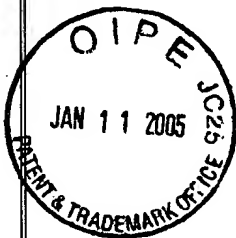
**U.S. PATENT DOCUMENTS**

EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	RE34,425	11/02/93	Schultz			04/30/92
	5,196,353	03/23/93	Sandhu et al.			01/03/92
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	6,120,349	09/19/00	Nyui et al.			06/26/97
	6,165,057	12/26/00	Gill, Jr.			05/15/98
EXAMINER			DATE CONSIDERED			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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**OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)**

July 1990. "Endpoint Technique for Chemical-Mechanical Polish." IBM Technical Disclosure Bulletin.

August 1992. "Endpoint Detection of Oxide Polishing and Planarization of Semiconductor Devices." IBM Technical Disclosure Bulletin.

EXAMINER

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